

PATENT  
04600/USA/IMPLANT/ORION/LE  
BSKB DOCK. NO. 1028-0171P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: LEDOUX et al. Conf.: 7224  
Appl. No.: 09/822,864 Group: 2881  
Filed: April 2, 2001 Examiner: Nguyen, K.T.  
For: METHOD AND SYSTEM FOR CONTROLLING BEAM  
SCANNING IN AN ION IMPLANTATION DEVICE

RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents  
Washington, DC 20231

April 28, 2003

Sir:

In reply to the Restriction Requirement dated February 26, 2003, the period for response having been extended one (1) month to expire on April 26, 2003, the following remarks are respectfully submitted in connection with the above-identified application.